

Application/Control No.	Applicant(s)/Patent under Reexamination SEMEIA, ROBERTO	
10/770,090		
Examiner	Art Unit	
John Rivell	3753	

SEARCHED							
Class	Subclass	Date	Examiner				
137	512.15 852 854	8/14/2006	\mathcal{X}				
128	200.29	8/14/2006					
· 128	204.26	8/14/2006	4/37				
128	204.27	8/14/2006	R				
128	205.24	8/14/2006	1/2				
128	207.12	8/14/2006	11/2				
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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	ce Search Printout	4/18/2007	K		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
		DATE	EXMR	
None		8/14/2006	R	
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